PATENT APPLICATION

Attorney Docket No. 8071-103 (OPP052118US)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT:

Hyun-Jae KIM et al.

INTERNATIONAL APPLN NO.:

PCT/KR2004/000520

INTERNATIONAL FILING DATE:

12 March 2004

SERIAL NO:

Unassigned

FILED:

Concurrently Herewith

FOR:

CRYSTALLIZATION APPARATUS AND METHOD OF AMOPHOUS

SILICON

Commissioner for Patents Box 1450 Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Prior to examination on the merits, please amend the above identified application as set forth hereinbelow:

CERTIFICATION UNDER 37 C.F.R. ' 1.10

hereby certify that this New Application Transmittal and the documents referred to as enclosed therein are being deposited with the United States Postal Service on this date September 13, 2005 in an envelope as "Express Mail Post Office to Addressee" Mail Label Number EV702320046US addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Frank Chau
(Type or print name of person mailing paper)
\mathcal{J}
(Signature of person mailing paper)